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Docket No. 740756-2659

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Shunpei YAMAZAKI et al.  
Serial No. 10/678,139  
Filed: October 6, 2003  
For: METHOD FOR FABRICATING  
SEMICONDUCTOR THIN FILM

- )
- ) Group Art Unit: 2822
- ) Examiner: Maria F. Guerrero
- ) Confirmation No. 9428
- ) Date: October 11, 2005

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[37 CFR 1.8(a)]

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Signature: 

Name: Jeffrey A. Costello

AMENDMENT

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 11, 2005, please amend the above identified application as follows.

W681271.1